



Docket No.: N9450.0046/P046
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Osamu Komuro, et al.

Examiner: Anthony G. Quash

Application No.: 10/079,855

Art Unit: 2881

Filed: February 22, 2002

For: PROCESS CONDITIONS CHANGE
MONITORING SYSTEMS THAT USE
ELECTRON BEAMS, AND RELATED
MONITORING METHODS

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

Commissioner for Patents
MS: AF
P.O. Box 1450
Alexandria, VA 22313-1450

*Please Enter
amendment
A 2*

Dear Sir:

This paper is in response to the Office Action dated December 5, 2003, finally rejecting claims 1-6. Please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.